Docket No.: 060188-0635

PATENT

### TES PATENT AND TRADEMARK OFFICE

In re Application of

Response Under 37 CFR 1.116 - Expedited Procedure

Customer Number: 20277

Shuji HIRAO, et al.

Confirmation Number: 4984

Corres. and Mail

Application No.: 10/643,980

Group Art Unit: 2825

Filed: August 20, 2003

Examiner: CARDID EVERHART

For: PRODUCTION METHOD OF SEMICONDUCTOR DEVICE

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached: 3 Technical Publications (16 pages)

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	35	23	12	\$50.00 =	\$600.00
Independent Claims	4 ·	3	1	\$200.00 =	\$200.00
		Multiple dependent claims newly presented			\$0.00
		Fee for extension of time			\$0.00
					\$0.00
Total of Above Calculations				\$800.00	

冈 Please charge my Deposit Account No. 500417 in the amount of \$800.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of  $\boxtimes$ extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

Registration No. 46,692

600 13th Street, N.W. Washington, DC 20005-3096 Phone: 202.756.8000 RMF:jrj Facsimile: 202.756.8087

Date: April 4, 2005

Please recognize our Customer No. 20277 as our correspondence address.



Docket No.: 60188-635 **PATENT** 

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

# **RESPONSE UNDER 37 C.F.R. 1.116 EXPEDITED PROCEDURE**

In re Application of

Customer Number: 20277

Shuji HIRAO, et al.

Confirmation Number: 4984

Application No.: 10/643,980

Group Art Unit: 2825

Filed: August 20, 2003

Examiner: Caridad Everhart

For:

PRODUCTION METHOD OF SEMICONDUCTOR DEVICE

## **AMENDMENT UNDER 37 C.F.R. 1.116**

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 3, 2005, having a three-month shortened statutory period for response set to expire on April 3, 2005 (Sunday), reconsideration of the aboveidentified application is respectfully requested in view of the following amendment and remarks.

04/05/2005 SFELEKE1 00000109 500417 10643980

01 FC:1201 02 FC:1202 200.00 DA 600.00 DA